

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

22313-1450

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Applicant(s): Z. Xie et al.

Case:

3-4

Serial No.:

10/623,983

Filing Date: Group:

June 21, 2003 2826

Examiner:

Fetsum Abraham

Title:

Shielding Structure for Use in a Metal-Oxide-Semiconductor Device

AMENDMENT TRANSMITTAL

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Submitted herewith are the following documents relating to the above-identified patent application:

(1) Amendment and Response to Office Action with enclosures.

There is no additional fee due in conjunction with the Amendment. In the event of any non-payment or improper payment of a required fee, the Commissioner is hereby authorized to charge or to credit Ryan, Mason & Lewis, LLP Deposit Account No. 50-0762 as required to correct the error.

Respectfully submitted,

Date: August 4, 2005

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Reg. No. 43,602

Attorney for Applicant(s) Ryan, Mason & Lewis, LLP

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AMENDMENT AND RESPONSE TO OFFICE ACTION

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In response to the non-final Office Action dated May 4, 2005, please amend the above-identified application as follows: